



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

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Shunpei YAMAZAKI, et al

)

Serial No. 09/466,828

) Group Art Unit: 2818

Filed: 12/20/99

) Examiner: Renee R. Berry

For: INSULATING FILM AND METHOD OF
PRODUCING SEMICONDUCTOR DEVICE

**REQUEST FOR ACKNOWLEDGMENT OF
INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents
P. O. Box 1450
Alexandria VA 22313-1450

Sir:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
The United States Postal Service with sufficient postage as First
Class Mail in an envelope addressed to: Commissioner for Patents,
P. O. Box 1450, Alexandria VA 22313-1450, on January 29, 2004

Renny J. Robinson

Applicants acknowledge with appreciation the Notice of Allowability and Issue Fee
Due form mailed July 2, 2003 acknowledging the filing of an Information Disclosure
Statement on March 3, 2003.

The Notice of Allowability did not, however, include an initialed Form PTO-1449
acknowledging the Information Disclosure Statements filed May 10, 2002 and April 2,
2003. Also, further Information Disclosure Statements were filed on October 2, 2003 and
December 16, 2003. The acknowledgements of these Information Disclosure Statements
are also outstanding. Therefore, it is respectfully requested that the Examiner evidence
consideration of the references cited in the IDS of May 10, 2002; April 2, 2003; October 2,
2003 and December 16, 2003 by providing a copy of the initialed Form PTO-1449.

If a conference would be beneficial in expediting the prosecution of the instant
application, the Examiner is invited to telephone the undersigned to arrange such a
conference.

Respectfully submitted,


Eric J. Robinson
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